



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re application of

Kazuhiro IKURUMI et al.

Serial No. 09/826,827

Filed April 6, 2001

: Confirmation No. 5095

: Docket No. 2001_0409A

: Group Art Unit 2817

: Examiner Justin P. Bettendorf

TECHNOLOGY CENTER 2800

8/ Elect
G. Stanley
11-12-02

METHOD AND APPARATUS FOR
ADJUSTING IMPEDANCE OF
MATCHING CIRCUIT

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

ELECTION

Assistant Commissioner for Patents,
Washington, D.C.

Sir:

Pursuant to the requirement contained in the Office Action mailed October 8, 2002,
Applicants hereby elect Group I, claims 1-13, drawn to a method of impedance matching.

In view of this election, a full examination on the merits of the present application is
respectfully requested.

Respectfully submitted,

Kazuhiro IKURUMI et al.

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